

**Notice of References Cited**

Application/Control No.

09/296,835

Applicant(s)/Patent Under  
Reexamination  
WEIMER ET AL.

Examiner

Erik Kielin

Art Unit

2813

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-			
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	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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	V	Ghandi, VLSI Fabrication Principles, 2nd ed. John Wiley & Sons: New York, 1994, pp. 465-466.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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